

<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b> (Not for submission under 37 CFR 1.99)	Application Number		10766336
	Filing Date		2004-01-28
	First Named Inventor	Shyh-Mei Ho	
	Art Unit	2175	
	Examiner Name	Stephen D. Alvesteffer	
Attorney Docket Number		SVL920030102US1	

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	4	6948117	B2	2005-09-20	Van Eaton et al.	
	5	7000238	B2	2006-02-14	Nadler et al.	
	6	7024413	B2	2006-04-24	Binding et al.	
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9	7054901	B2	2006-05-30	Shafer	
10	7111011	B2	2006-09-19	Graves et al.	
11	7120645	B2	2006-10-10	Manikutty et al.	
12	7120702	B2	2006-10-10	Huang et al.	
13	7124299	B2	2006-10-17	Dick et al.	
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17	7296226	B2	2007-11-13	Junkermann	
18	6816883	B2	2004-11-09	Baumeister et al.	
19	6067579		2000-05-23	Hardman et al.	

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20	6097688		2000-08-01	Ichimura et al.	
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	1	Jouko Jantti et al., "IMS Version 9 Implementation Guide", ibm.com/redbooks, pages 139-143.	<input type="checkbox"/>

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